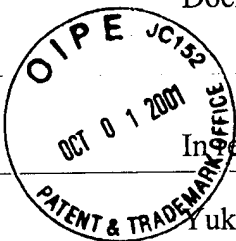


#2 FDS
10-70-01
R. H. Hines

Docket No.: 50090-233

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yukihiro NAGAI, et al.

Serial No.: 09/631,623

Group Art Unit: 2812

Filed: August 04, 2000

Examiner: M. Kirk

For: SEMICONDUCTOR DEVICE HAVING A POTENTIAL FUSE, AND METHOD OF
MANUFACTURING THE SAME

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

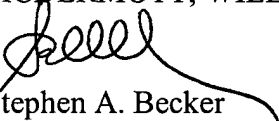
Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein.

09/631,623

A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Stephen A. Becker
Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SAB:kjw
Date: October 1, 2001
Facsimile: (202) 756-8087